

FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION Express Mail Number <u>EV342447038845</u> <i>(Use several sheets if necessary)</i>					Docket Number (Optional) 100-22400 (P05620)		Application No. NEW <u>10/625,010</u>	
					Applicant(s) Kevin Weaver et al.			
					Filing Date Herewith		Group Art Unit Unknown <u>2818</u>	

U.S. PATENT DOCUMENTS												
EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TH	6	2	1	1	5	2	7	04/03/01	Chandler	250	492.2	02/11/99
TH	6	4	9	2	2	6	1	12/10/02	Gavish et al.	438	637	12/30/00

FOREIGN PATENT DOCUMENTS														
	DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	Translation		
													Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
TH	Caiwen Yuan et al., "Application of Focused Ion Beam in Debug and Characterization of 0.13µm Copper Interconnect Technology", Proceedings from the 28 th International Symposium for Testing and Failure Analysis, November 3-7, 2002, Phoenix, Arizona, pp. 183-188.

EXAMINER <u>TU-TU +10</u>	DATE CONSIDERED <u>Feb, 2005</u>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.